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(54) METHOD OF MANUFACTURING POSITIVE ELECTRODE MATERIAL

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(57) **ABSTRACT**

A positive electrode material has diffraction peaks at 2θ=13.1°±0.2°, 14.0°±0.2°, and 18.4°±0.2° in X-ray diffraction (2θ=5° to 90°) using synchrotron radiation having a wavelength of 1 Å, has a monoclinic crystal structure belonging to a space group $P2_1/c$, and is represented by a composition formula $Li_{2-2x}Co_{1+x}P_2O_7$ ($-0.2 \leq x \leq 0.2$).